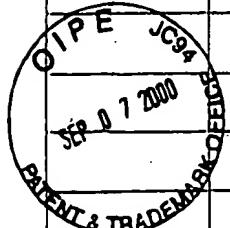


Form PTO-1449	Document Number (Examiner)	Assignment Number
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		TSMC-00-004 09/604,067
(Use several sheets if necessary)	Applicant	Ming-Dou Ker et al.
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U. S. PATENT DOCUMENTS



FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (including Author, Title, Date, Portion or Pages, Etc.)

Dr. J. Dabral et al., "Core Clamps for Low Voltage Technologies, EPS/ESD Symp. Proc., 1994, EOS-16, pp. 141-149.

Dr. J. Worley et al., "Sub-Micron Chip ESD Protection Schemes which Avoid Avalanche Junctions", EOS/ESD Symp. Proc., 1995, EOS-17, pp. 13-20.

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